

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

O I P E  
FEB 19 2003  
U.S. PATENT & TRADEMARK OFFICE  
In re application of: ANNAPRAGADA et al.  
Application No.: 09/746,900

Attorney Docket No.:  
LAM1P157/P0718

Filed: December 22, 2000

Examiner: CROWELL, Anna M.  
Group: 1763

Title: METHOD OF ETCHING WITH NH3 AND  
FLUORINE CHEMISTRIES

CERTIFICATE OF MAILING  
I hereby certify that this correspondence is being deposited with the  
United States Postal Service as First Class Mail to: Box Non-Fee  
Amendment, Commissioner for Patents, Washington, D.C. 20231 on  
February 11, 2003.

Signed: Sue Funchess  
Sue Funchess

HYA  
2/26/03  
mw

AMENDMENT A

Box Non-Fee Amendment  
Commissioner for Patents  
Washington, D.C. 20231

Dear Sir or Madame:

RECEIVED  
FEB 25 2003  
TC 1700 MAIL ROOM

This is in response to the office action mailed November 12, 2002. The period of response extends to February 12, 2002. Please consider the following remarks and amend the above-identified patent application as follows:

In The Specification:

On page 12, lines 18-27, please amend the paragraphs as follows:

"Another embodiment of the invention may use a combined resist strip and barrier etch step to reduced etching damage as described in U.S. Patent [Application No. \_\_\_\_\_]  
(Attorney Docket Number LAM1P158) No. 6,518,174 entitled "A Combined Resist Strip And Barrier Etch Process For Dual Damascene Structures" by Rao Annapragada and Reza Sadjadi, with the same filing date, and which is incorporated by reference."

**BEST AVAILABLE COPY**

1763  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

O I P E  
FEB 19 2003  
PATENT & TRADEMARK OFFICE

Initial application of: ANNAPRAGADA et al.

Attorney Docket No.: LAM1P157/P0718

Application No.: 09/746,900

Examiner: CROWELL, Anna M.

Filed: December 22, 2000

Group: 1763

Title: METHOD OF ETCHING WITH NH<sub>3</sub>  
AND FLUORINE CHEMISTRIES

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Box Non-Fee Amendment, Commissioner for Patents, Washington, D.C. 20231 on February 11, 2003.

Signed: Sue Funchess

Sue Funchess

AMENDMENT A TRANSMITTAL

TC 1700 MAIL ROOM  
FEB 25 2003  
RECEIVED

Commissioner for Patents  
Washington, DC 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	19	MINUS	20	0	x 9 =	x 18 = \$-0-
Independent Claims	2	MINUS	3	0	x 42 =	x 84 = \$-0-
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
				Total	\$	\$-0-

Applicant(s) hereby petition for a \_\_\_\_\_ month extension(s) of time to respond to the aforementioned Office Action.

Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0388 (Order No. LAM1P157).

Enclosed is our Check No. \_\_\_\_\_ in the amount of \$\_\_\_\_\_ to cover the additional claim fee and/or extension of time fees.

Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 50-0388 (Order No. LAM1P157).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP

*Michael Lee*

Michael Lee  
Reg. No. 31,846

P.O. Box 778  
Berkeley, CA 94704-0778

BEST AVAILABLE COPY